PATENT ASSIGNMENT

Electronic Version v08 Stylesheet Version v02

SUBMISSION TYPE:

NEW ASSIGNMENT

APPLICATION NUMBER

11/308303

NATURE OF CONVEYANCE:

ASSIGNMENT OF ASSIGNOR'S INTEREST

CONVEYING PARTY DATA

Name	Execution Date	
Ter-Chang Huang	2006-03-10	
Hung-Yi Lin	2006-03-10	
Wen-Syang Hsu	2006-03-10	

RECEIVING PARTY DATA

Name	Street Address	Internal Address	City	State/Country	Postal Code
11	No. 566, Gaoshih Rd., Yangmei Township		Taoyuan County	TAIWAN	

CORRESPONDENCE DATA

FAX NUMBER: 8064986673

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

When the customer number has been provided, the Office of Public Records will obtain the correspondence data from the

official record on file at the USPTO. CUSTOMER NUMBER: 027765

 NAME OF PERSON SIGNING:
 WINSTON HSU

 DATE SIGNED:
 2006-03-13

Total Attachments: 2

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PATENT REEL: 017311 FRAME: 0830

800025061

Docket No TMIP0020USA

ASSIGNMENT OF INVENTION

In consideration of the payment by ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration.

ASSIGNOR(S) (Inventors):

NPO#TMI-P0020-USA:0 CUST#tMt0044

	Name:	Ter-Chang Huang Nationality: R.O.C.	alada Maria da Maria				
	Address:	No. 26, Community 4, San-yi Tsun, Liouchiao Hsiang, Chia-Yi Hsien, R.O.C.	Taiwan,				
	Name:	Hung-Yi Lin Nationality: R.O.C.					
	Address:	10F, No. 166-12, Fenghua Rd., Nanhsing Tsun, Luchu Hsiang, Tao-Yua Taiwan, R.O.C.	an Hsien,				
	Name:	Wen-Syang Hsu Nationality: R.O.C.					
	Address:	: 16F-2, No. 25, Chianchong 1st Rd., East Dist., Hsin-Chu City, Taiwan,	R.O.C.				
**1							
		assigns and transfers to					
ASSI	GNEE(S)	S):					
	Name:	Touch Micro-System Technology INC.					
	Address:	: No. 566, Gaoshih Rd., Yangmei Township, Taoyuan County 326, Taiw	an, R.O.C.				
and the successors and assignees of the ASSIGNEE the entire right, title, and interest in and to any and all improvements which are disclosed in the invention entitled:							
"METHOD OF FORMING A CAVITY BY TWO-STEP ETCHING AND METHOD OF REDUCING DIMENSION OF A MEMS DEVICE"							
Which is found in:							
(a) U.S. patent application executed on even date							
(b) _		U.S. patent application executed on					
(c)_		U.S. application serial no.					
(d)_	F	patent no. issued					

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PATENT REEL: 017311 FRAME: 0831

F#NPO-P0002E-US1

DSB0-095U001564

PATENT

and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuations, continuation-in-part, divisions, renewals, substitutes, or extensions thereof, and as to Letters Patent any reissue or re-examination thereof

ASSIGNOR hereby covenants that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the proposes thereof.

MAR. 1 O 2006 IN WITNESS WHEREOF, We have hereunto set hand and seal this _____ (Date of signing)、(請發明人務必簽署上列日期・)

(Type name of inventor)

Ter-Chang Huang

Hung-Yi Lin

Wen-Syang Hsu

Ter-Chang Hungy
Hung-To Lon
Men-Gyang Hear

Assignment, Page 2 of 2

F#NPO-P0002E-US1 DSB0-095U001564

NPO#TMI-P0020-USA:0 CUST#tMt0044

RECORDED: 03/15/2006

PATENT REEL: 017311 FRAME: 0832